

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Katsumi SHIBAYAMA et al.	)	Confirmation No.: 7829
	)	
U.S. Application No.: 10/541,618	)	Group Art Unit: 2814
	)	
Filed: May 5, 2006	)	Examiner: Anh D. Mai
	)	
For: WIRING SUBSTRATE AND RADIATION	)	
DETECTOR USING THE SAME	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop Amendment**  
Alexandria, VA 22314

Sir:

**RESPONSE TO RESTRICTION/ELECTION REQUIREMENT**

In an Office Action dated January 26, 2009, the period for response to which runs through February 26, 2009, the Examiner required election under 35 U.S.C. § 121 and 372 between the claims of Group I (claims 1-5) allegedly drawn to “a wiring substrate,” and Group II (claims 6-9) allegedly drawn to “radiation detector.”

Applicants hereby elect Group I (claims 1-5) for examination.

Applicants respectfully request formal examination of this application.

Applicants respectfully submit that no fee is due in connection with the filing of this response. However, if there are any fees due in connection with the filing of this response, **except** for issue fees payable under 37 C.F.R. § 1.18, the Commissioner is hereby authorized by this paper to charge any such fees during the entire pendency of this application, including fees due under 37 C.F.R. §§ 1.16 and 1.17 which may be required and including any required

extension of time fees, *or* credit any overpayment to Deposit Account No. 50-0573. This paragraph is intended to be a **CONSTRUCTIVE PETITION FOR EXTENSION OF TIME** in accordance with 37 C.F.R. § 1.136(a)(3).

Respectfully submitted,

**DRINKER, BIDDLE & REATH LLP**

Dated: February 25, 2009

By:



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